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Application No.	Filing Date	Examiner	Group Art Unit
10/798,157	3/11/2004	Lee, Sin J.	1752
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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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Applicant: Li et al.

Examiner: Lee, Sin J.

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Serial No.: 10/798,157

Art Unit: 1752

Filed: 3/11/2004

For: NEGATIVE PHOTORESIST AND METHOD OF USING THEREOF

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Request for Reconsideration

Sir:

This Request for reconsideration is in response to the Office Action mailed December 14,

2004.